

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/618,067 Confirmation No. 4314
Applicant : Jifa Hao, et al.
Filed : July 11, 2003 Art Unit: 2822
Title : DENSE TRENCH MOSFET WITH DECREASED ETCH
SENSITIVITY TO DEPOSITION AND ETCH PROCESSING
Examiner : Rose, Kiesha L.
Docket No. : 3016429
Customer No. : 44,331

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

Responsive to the June 5, 2007 Office Action, Applicants submit the following
Amendment:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 4 of this paper.